

INFORMATION DISCLOSURE STATEMENT

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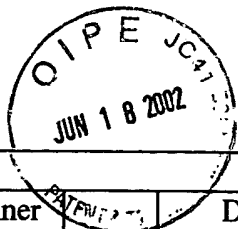
Applicant: Mona Masghati, *et al.*

Group: Unknown

Filed: June 10, 2002

Examiner: Unknown

S. SEYRAFI.



U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date if appropriate
AA	5,940,562	Aug. 17, 1999	Henson, <i>et al.</i>	385	88	
AB	5,644,668	Jul. 1, 1997	Chambers, <i>et al.</i>	385	90	
AC						
AD						
AE						
AF						

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AG	WO 91/06022	May 2, 1991	PCT	G02B	6/36		
AH	EP 0 717 297 A2	Jun. 19, 1996	Europe	G02B	6/42		
AI	WO 00/42464	Jul. 20, 2000	PCT	G02B	6/42		
AJ	EP 0 529 953 A1	Mar. 3, 1993	Europe	B23K	33/00		
AK	EP 0 463 457 A2	Jan. 2, 1992	Europe	H05K	13/00		
AL	EP 0 542 444 A1	May 19, 1993	Europe	G02B	6/32		

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AM	Koh, H. J., <i>et al.</i> , "On-Wafer Process for Mass Production of Hybridly Integrated Optical Components Using Passive Alignment on Silicon Motherboard," 1999 <i>Electronic Components and Technology Conference, IEEE</i> , pages 216-221 (June 1-4, 1999).

Examiner

S. Seyrafi

Date Considered

10/30/02

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.